

PATENT

Serial No. 10/574,145

Amendment in Reply to Office Action mailed on April 15, 2008

IN THE ABSTRACT

Please delete the current Abstract in its entirety and  
substitute therefor the enclosed New Abstract.

NEW ABSTRACT

A device such as a flexible AMLCD includes first and second layers, wherein the first layer is a flexible substrate and the second layer is a brittle ITO conduction line applied to the substrate. The ITO layer has a corrugated structure and is in contact with the substrate along a substantial portion of the length of the ITO layer so as to prevent fracture of the ITO layer when the flexible substrate is deformed. The ITO layer may be divided into portions, the length of the portions being selected to prevent fracture when the flexible substrate is deformed to a predetermined radius of curvature.